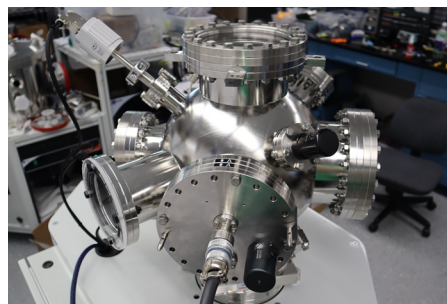
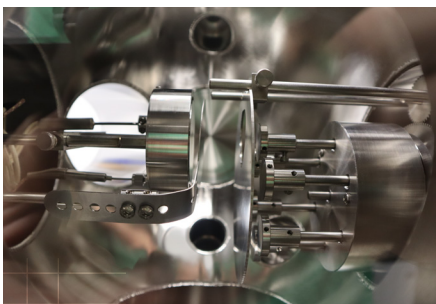


Pulsed Laser Deposition (PLD)

Thin Film R&D Star

- Multi-ports electro-polished UHV stainless steel chamber
- Pulsed Laser Deposition, can be integrated with Thermal Evaporation & Sputtering
- Independent oxygen resistant substrate heater and optimal rotation
- Gas flow using needle valve or Mass flow controller
- Standard pressure gauges
- Turbo Molecular Pump backed by dry rough pump
- Optional stainless steel load lock chamber
- Optional motorized control of substrate to source distance
- Excellent tool for nano and thin film metal-oxides, nitrides, carbides, and metals and Multilayer/Superlattices



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